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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: I. Soward
Haruhito ONO et al.)	
	:	Group Art Unit: 2822
Application No.: 09/819,737)	
	:	
Filed: March 29, 2001)	
	:	
For: ELECTROOPTIC SYSTEM ARRAY,)	
CHARGED-PARTICLE BEAM	:	
EXPOSURE APPARATUS USING THE)	:	February 6, 2003
SAME, AND DEVICE	:	
MANUFACTURING METHOD)	

Commissioner for Patents
Washington, D.C. 20231


POWER TO INSPECT AND MAKE COPIES

Sir:

Please permit C.T. Tran of FITZPATRICK, CELLA, HARPER & SCINTO to inspect and make copies of any and all papers in the Patent and Trademark Office file of the above-identified application.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Steven E. Warner
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